



Attorney Docket No. 0756-2422

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hideto OHNUMA

Serial No. 10/053,572

Filed: January 24, 2002

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 2812

) Examiner: J. Kennedy

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
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) 2005.

Adrian M. Stamper

AFTER FINAL AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 16, 2005, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.